

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of

Group 1795

Steven A. Soper *et al.*

Examiner Lee, Sin J.

Serial No. 10/734,816

Confirmation No. 3513

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For: Photoresist-Free Micropatterning on Polymer Surfaces (File Soper 0023.1)

**RESPONSE TO OFFICE ACTION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

This paper is submitted in response to the January 2, 2008 Office Action.